

Notice of References CitedApplication/Control No.
10/084,182Applicant(s)/Patent Under
Reexamination
NAKANISHI ET AL.Examiner
Yvette C. ThorntonArt Unit
1752

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2002/0034704 A1	03-2002	Oomori et al.	430/270.1
	B	US-6,492,086 B1	12-2002	Barclay et al.	430/270.1
	C	US-5,952,151 A	09-1999	Sondergeld, Manfred	430/270.1
	D	US-5,846,690 A	12-1998	Padmanaban et al.	430/284.1
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	MACHINE TRANSLATION FROM JPO WEBSITE JP 2001-027809 ITANI ET AL. "CHEMICAL AMPLIFICATION SERIES POSITIVE TYPE RESIST".
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.